



**ELECTRONIC COPY**

LG771667556  
Report verification at igi.org



February 6, 2026  
IGI Report Number **LG771667556**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**  
Measurements **10.95 X 7.72 X 5.24 MM**  
**GRADING RESULTS**  
Carat Weight **3.88 CARATS**  
Color Grade **D**  
Clarity Grade **VS 1**

**LABORATORY GROWN DIAMOND REPORT**

February 6, 2026  
IGI Report Number **LG771667556**  
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Shape and Cutting Style **CUT CORNERED RECTANGULAR  
MODIFIED BRILLIANT**  
Measurements **10.95 X 7.72 X 5.24 MM**

**GRADING RESULTS**

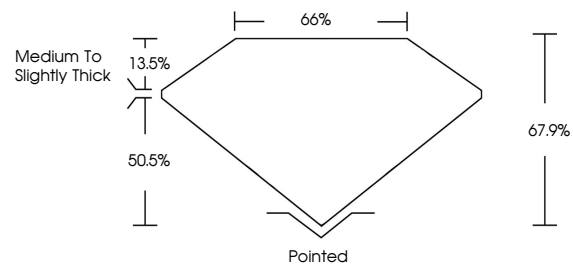
Carat Weight **3.88 CARATS**  
Color Grade **D**  
Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG771667556**

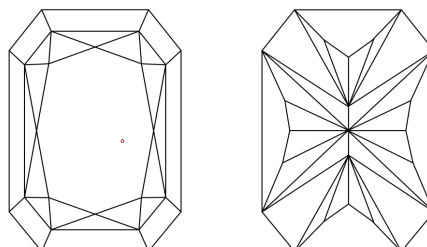
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

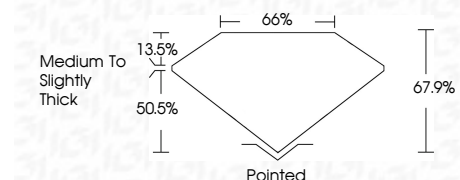
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Symmetry **EXCELLENT**  
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**IGI**



February 6, 2026  
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CUT CORNERED RECT. MODIFIED BRILLIANT  
10.95 X 7.72 X 5.24 MM  
3.88 CARATS  
D  
3.88 CARATS  
D  
VS 1  
67.9%  
50.5%  
Medium to Slightly Thick  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG771667556

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Type IIa